



GRAN SASSO
SCIENCE INSTITUTE



Updates on Electron Gun @ LNGS

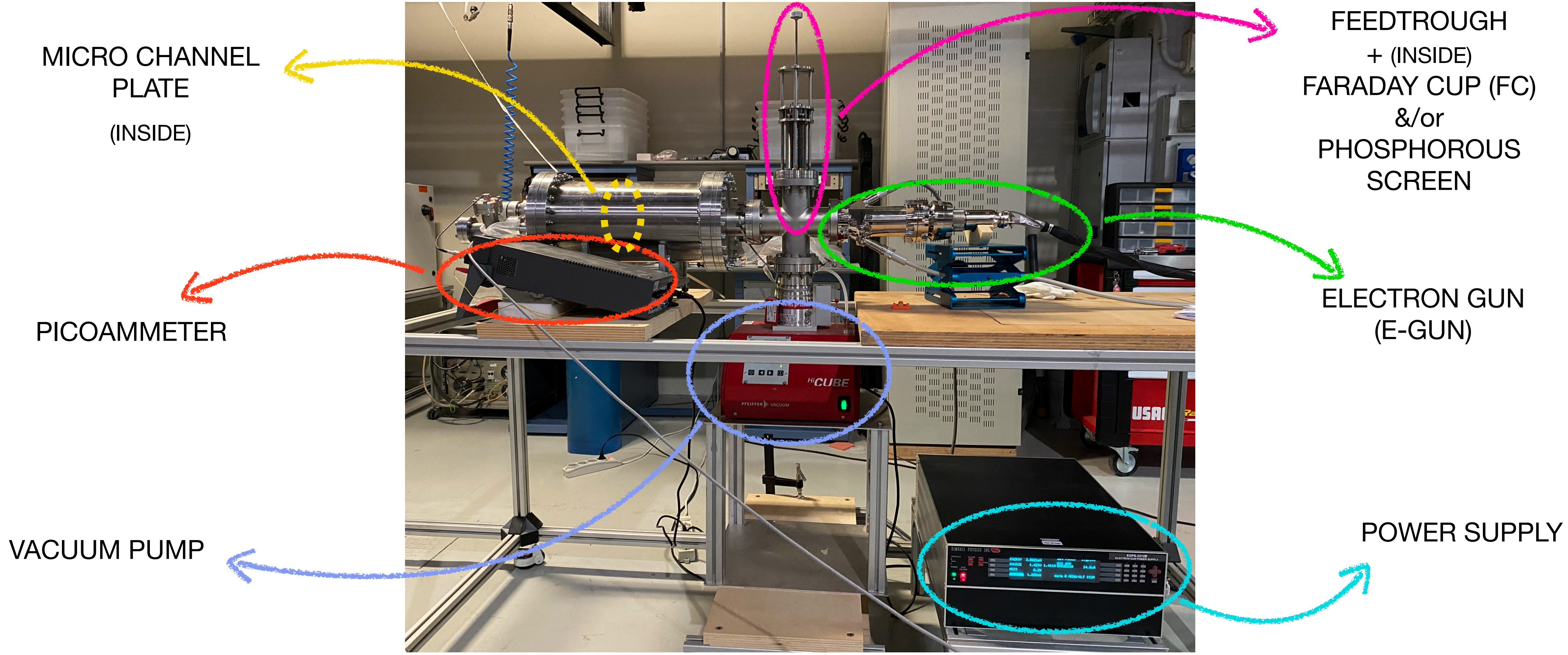
Presentation for PTOLEMY National Meeting - Rome, 19 February 2025

Francesca Maria Pofi - GSSI, INFN LNGS



PTOLEMY

How the Full Setup Looks Like



MICRO CHANNEL
PLATE
(INSIDE)

PICOAMMETER

VACUUM PUMP

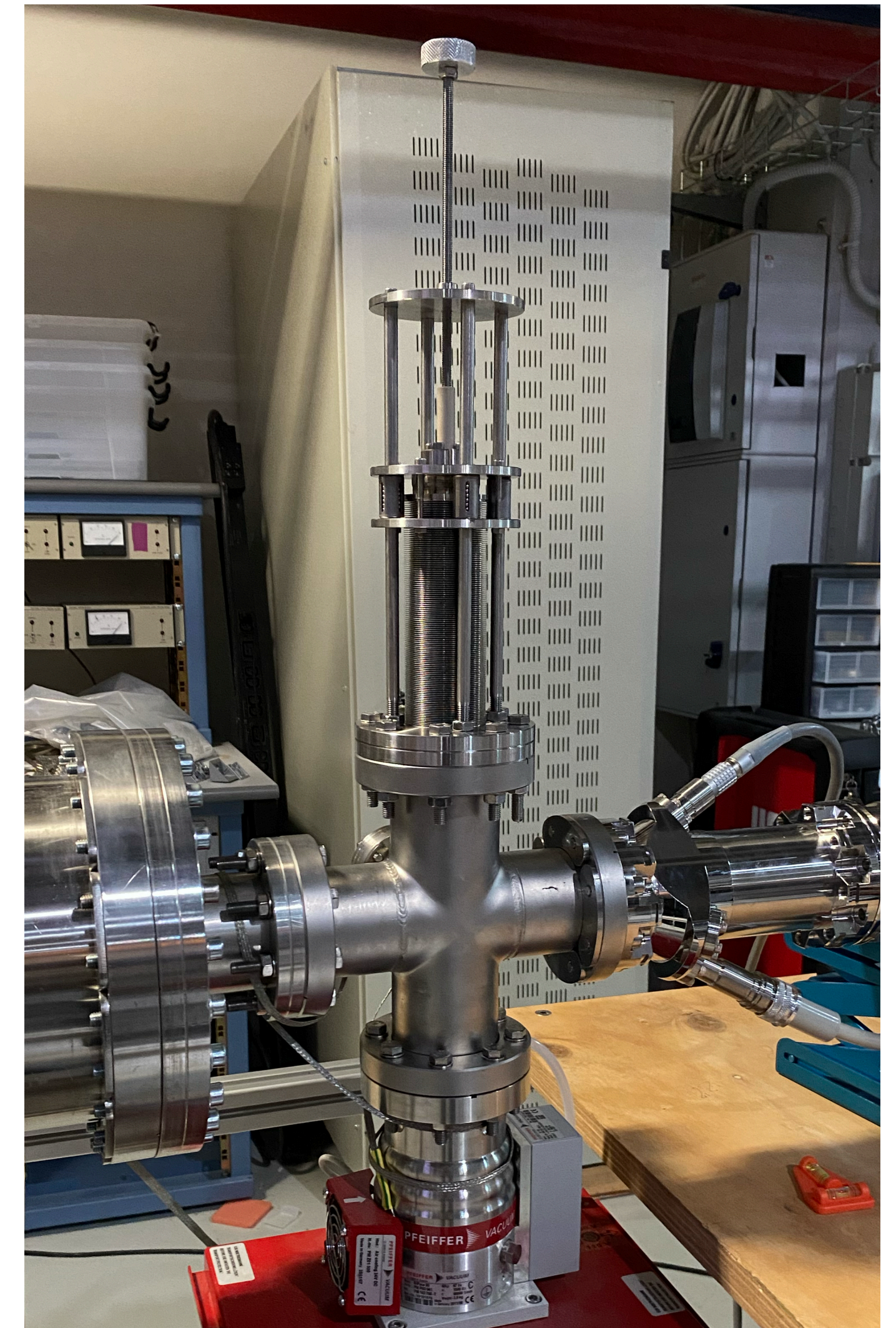
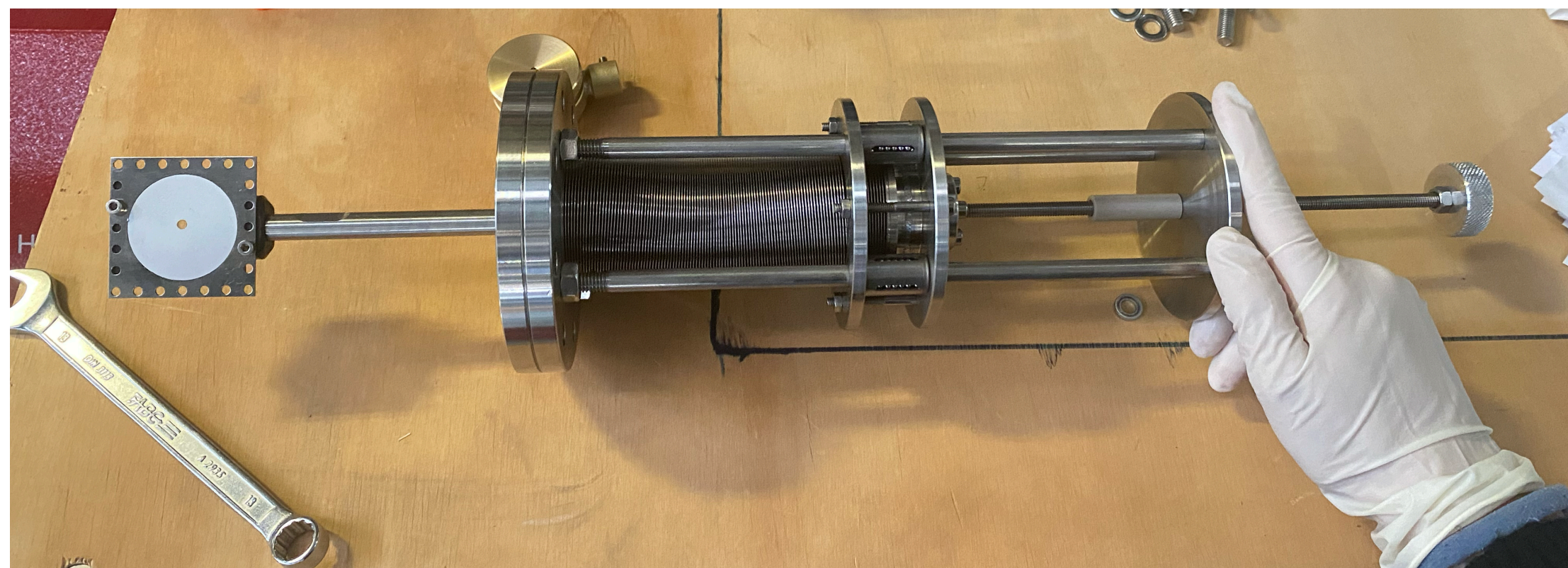
FEEDTROUGH
+ (INSIDE)
FARADAY CUP (FC)
&/or
PHOSPHOROUS
SCREEN

ELECTRON GUN
(E-GUN)

POWER SUPPLY

A Versatile Setup

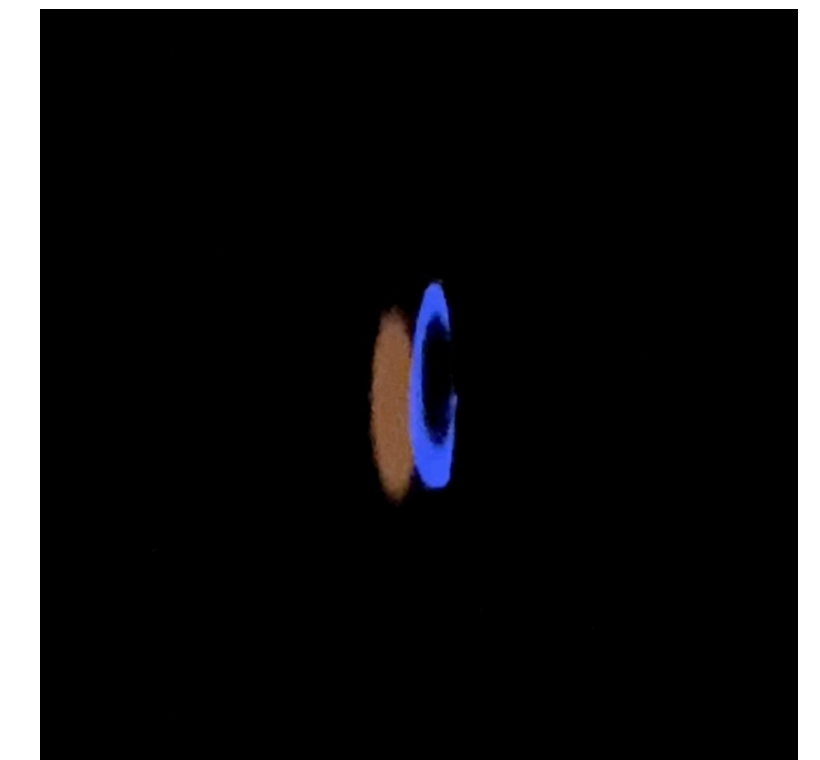
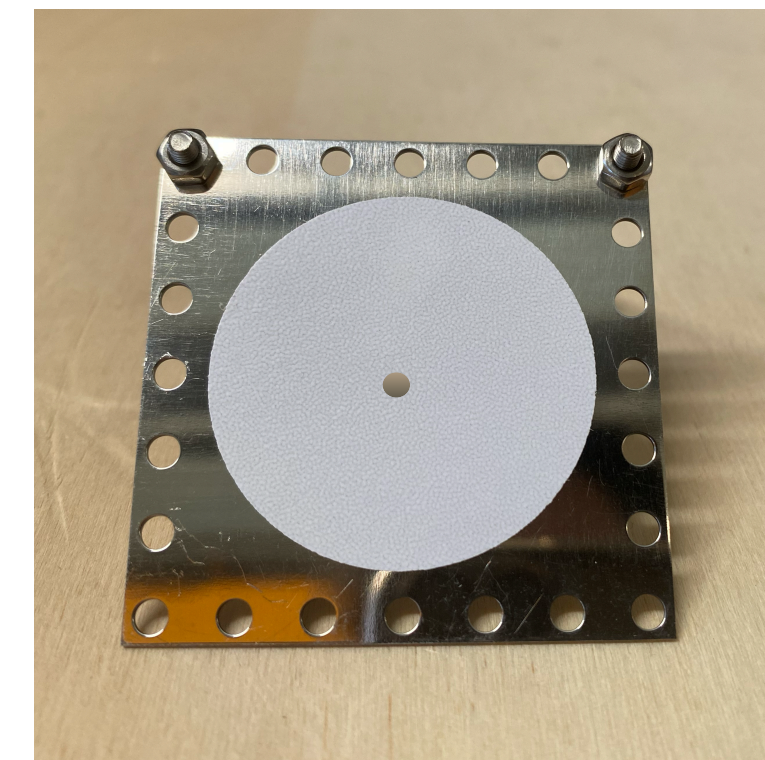
- ▶ Faraday cup &/or phosphor screen mounted on a feedthrough
 - ✓ Custom-made, in collaboration with LNGS Mechanics Workshop
 - ✓ Allows shifts on y-axis with sub-mm precision
 - ✓ Allows to completely remove beam monitoring unit from beam path



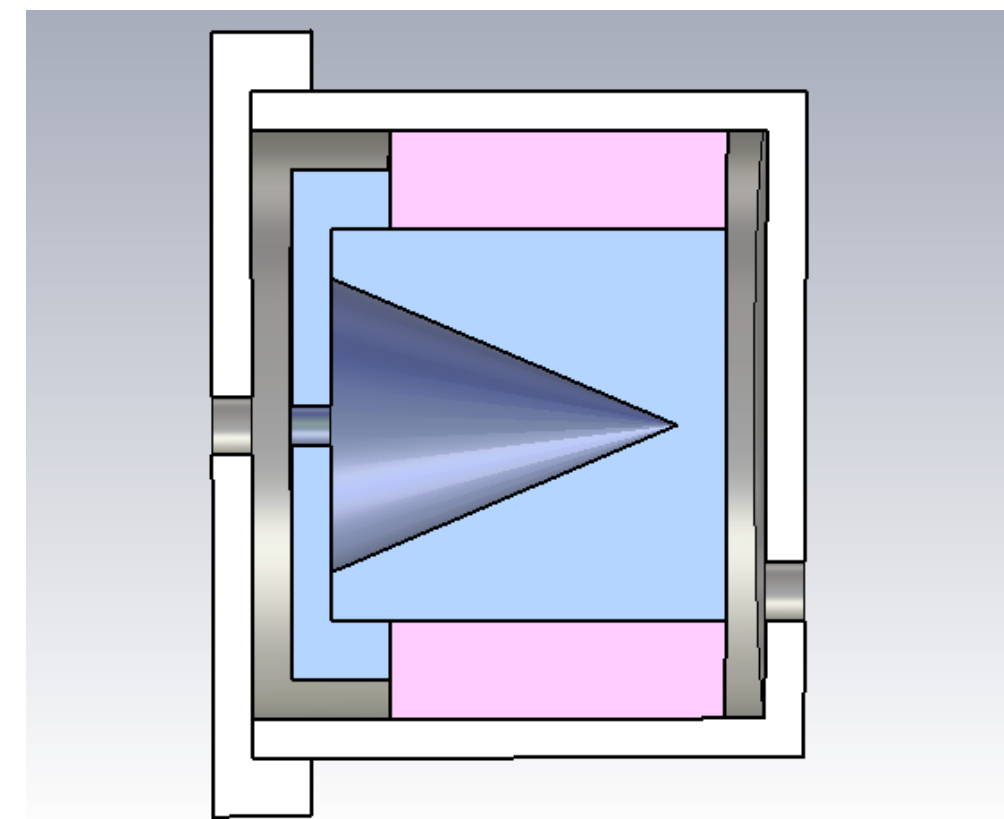
Output Monitoring: Ingredients

- ▶ Phosphorous screen:
High luminosity blue phosphor disk, 4 cm diameter & 75 μm thickness on stainless steel

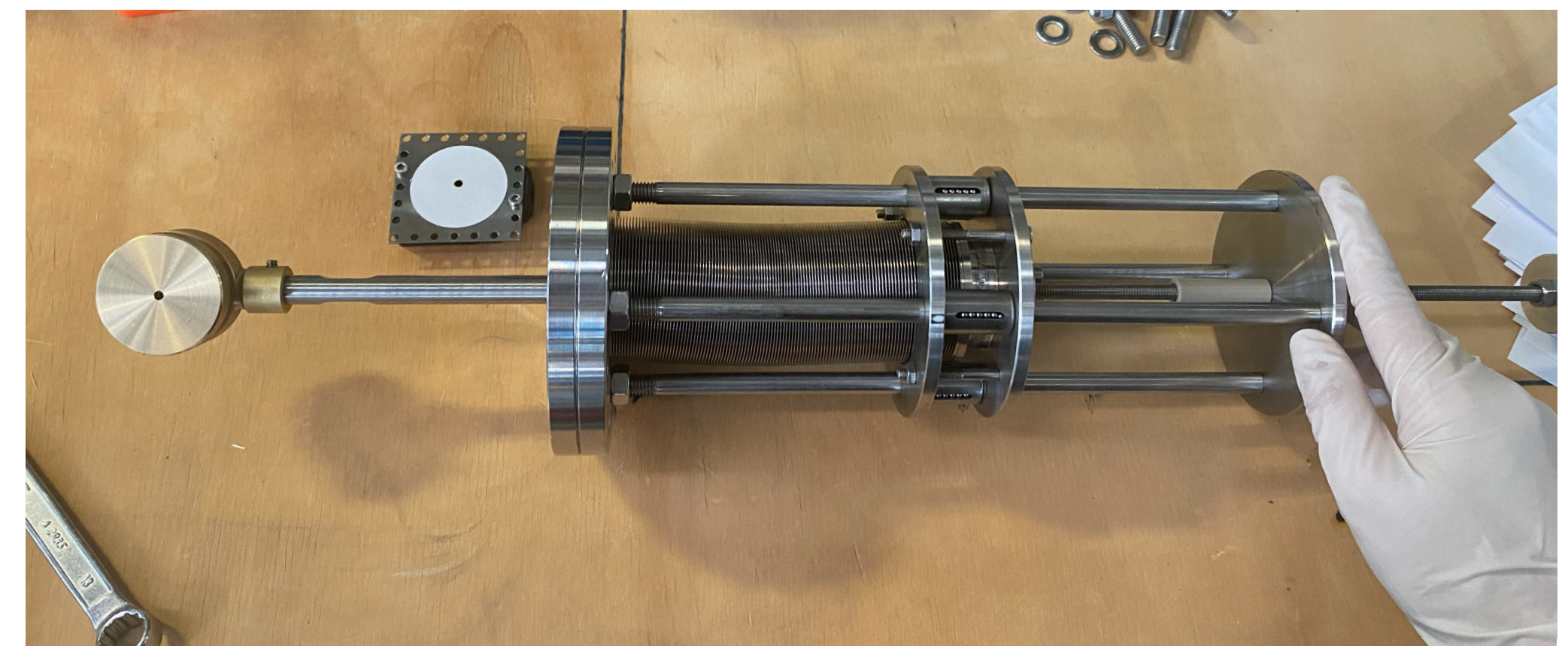
- for preliminary gun focusing & centering



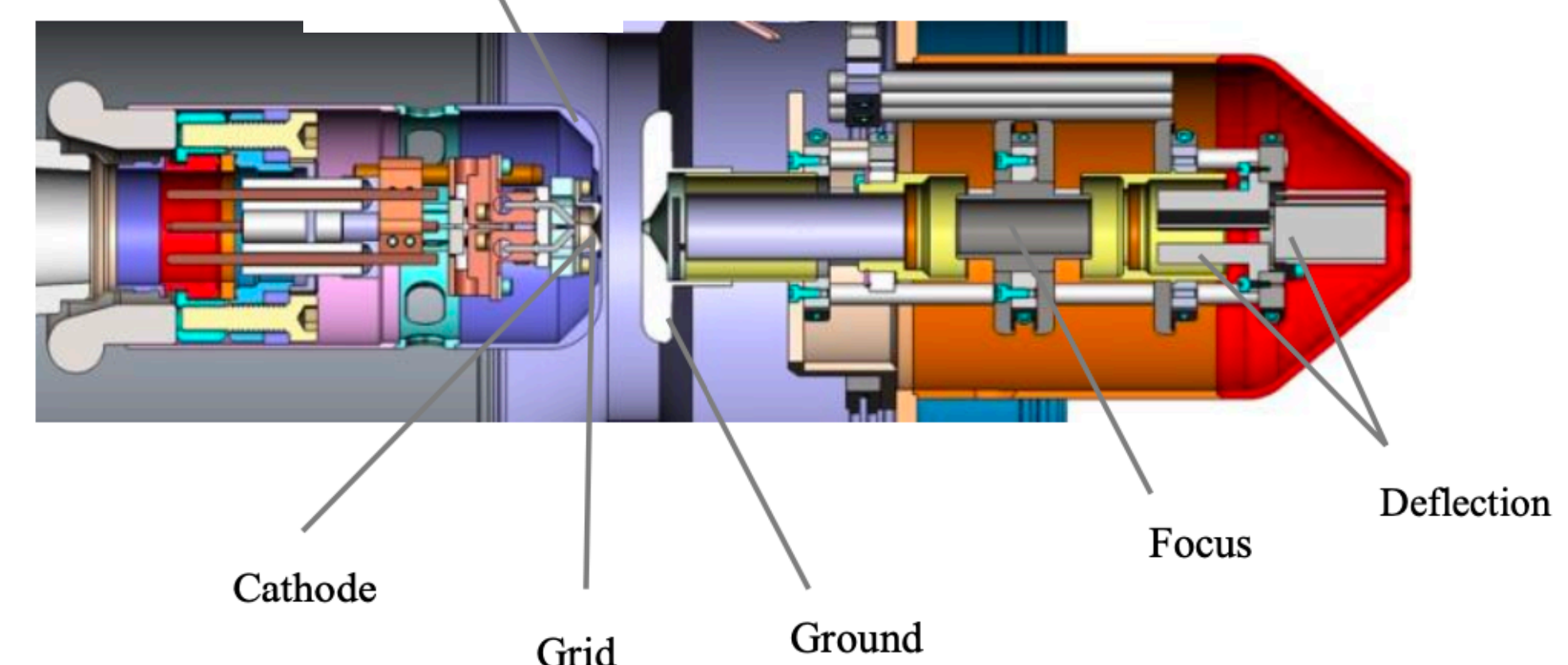
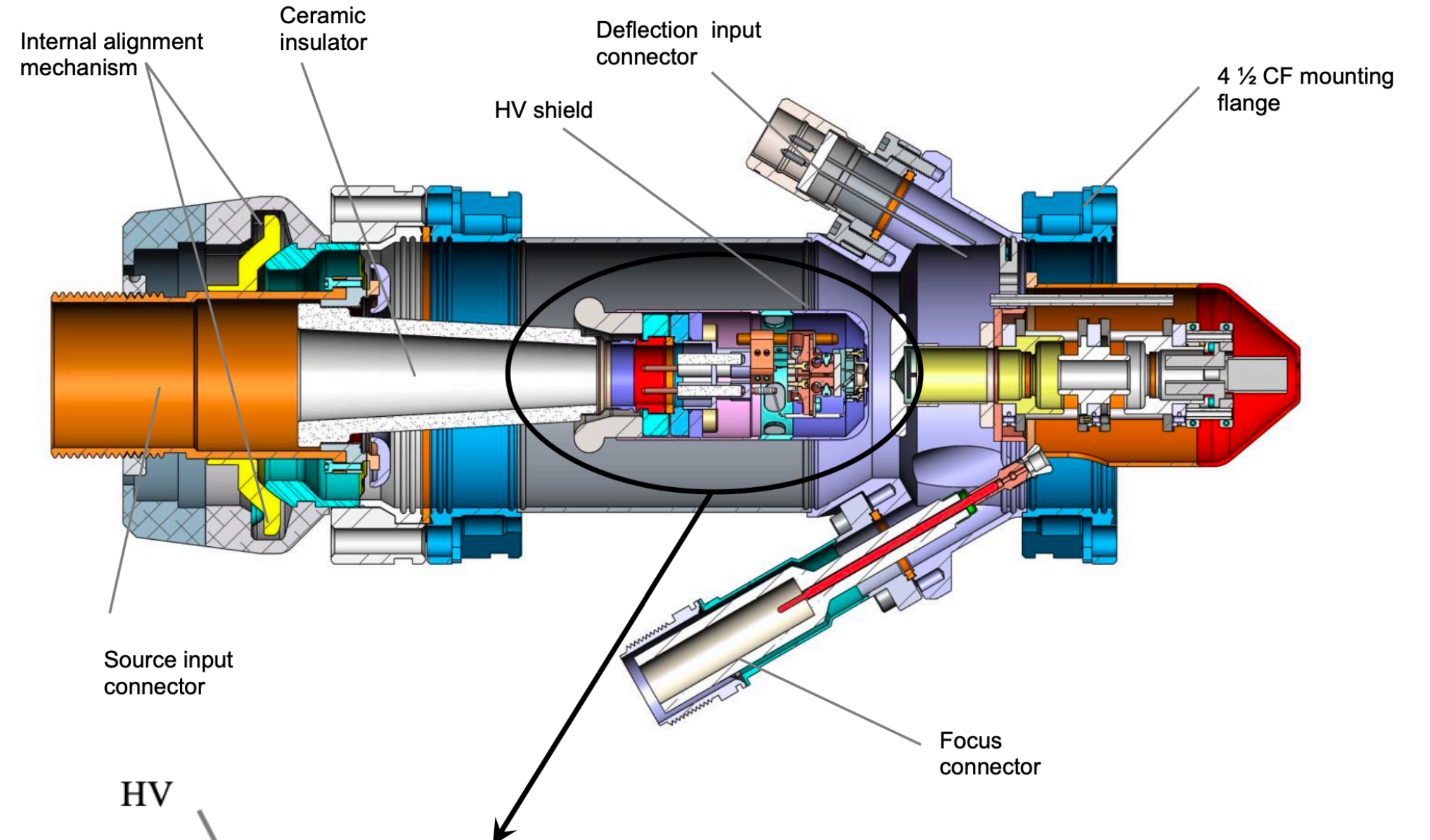
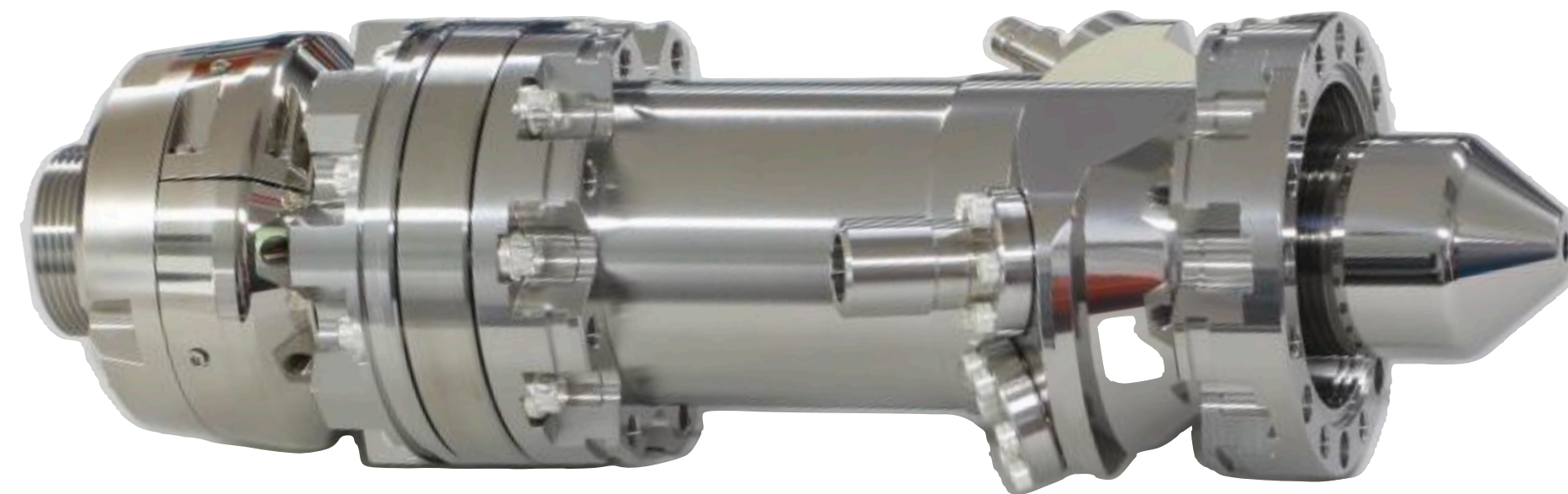
- ▶ Brass double Faraday cup



- Outer grounded to shield, 3 mm hole diameter
- Inner to read current, 3.5 mm hole diameter



What's Inside?



- ▶ Grounded Anode
- ▶ HV to accelerate electrons (up to -20 kV)
- ▶ Wehnelt (or grid, up to -500 V)
- ▶ Focus system (Einzel lens, up to -20 kV)
- ▶ X/Y deflection plates (up to ± 300 V)

Wehnelt as a Beam Intensity Filter

▶ What is?

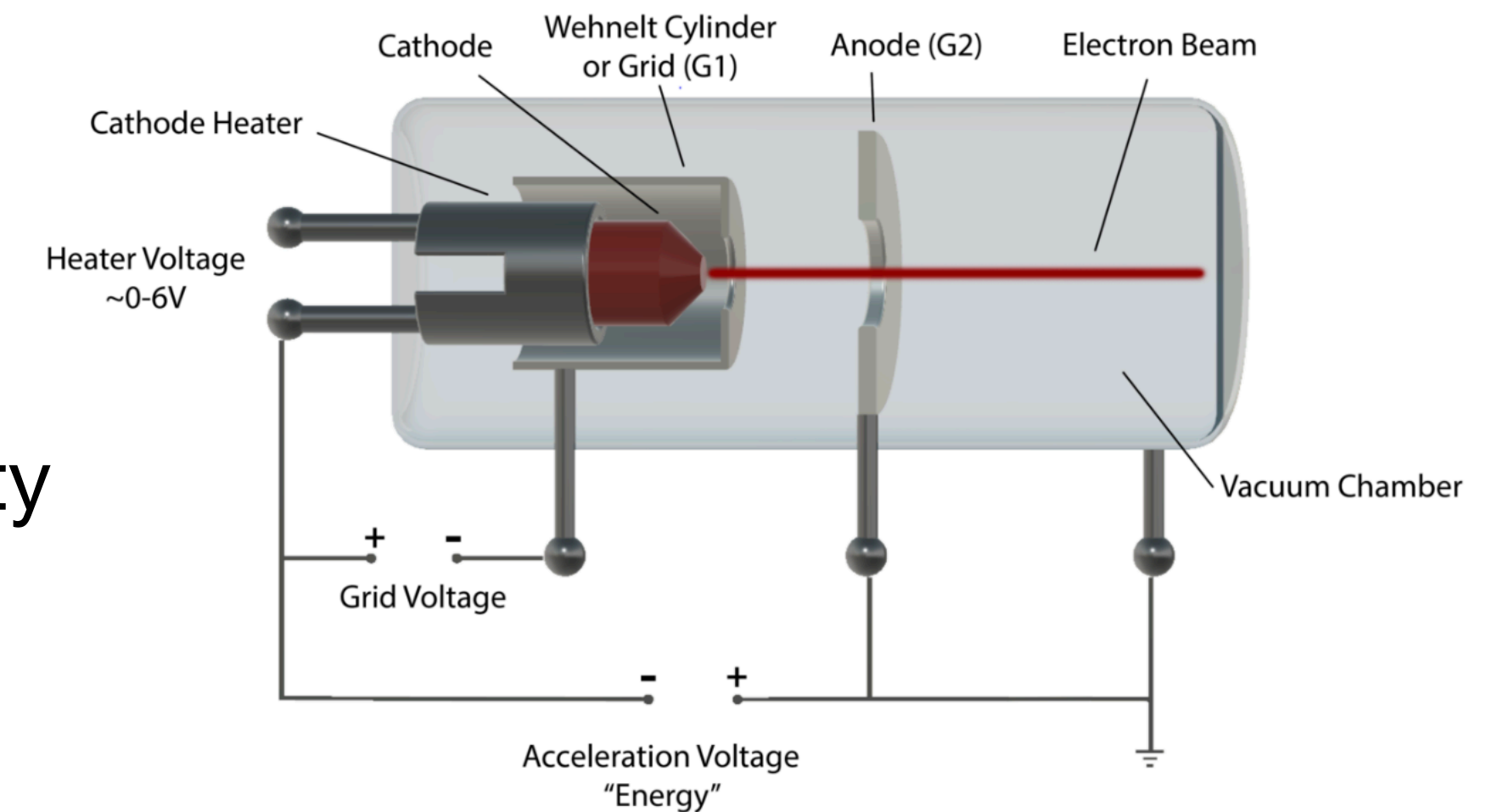
- Tubular housing for cathode with fixed aperture
- Negative bias → secondary electric field in cathode proximity

▶ How can be employed?

- Mid-range voltage → adjust beam divergence & uniformity → beam characterization (spot size, I-V curve etc.)
- High voltage → reduce electron emission from cathode edges till complete beam suppression

→ **Beam Intensity Filter**

possible needing for future usage as *electron trap calibration source*



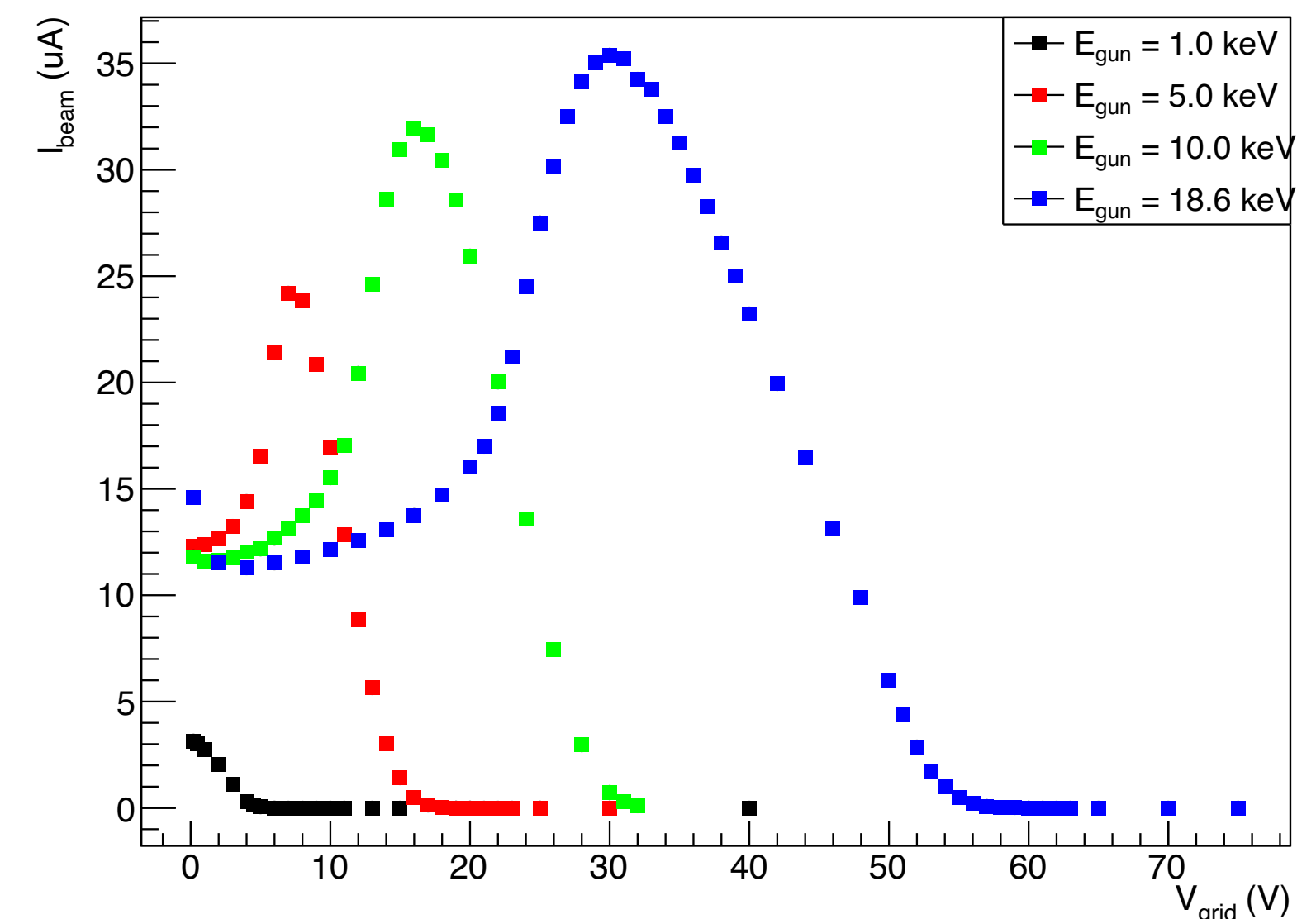
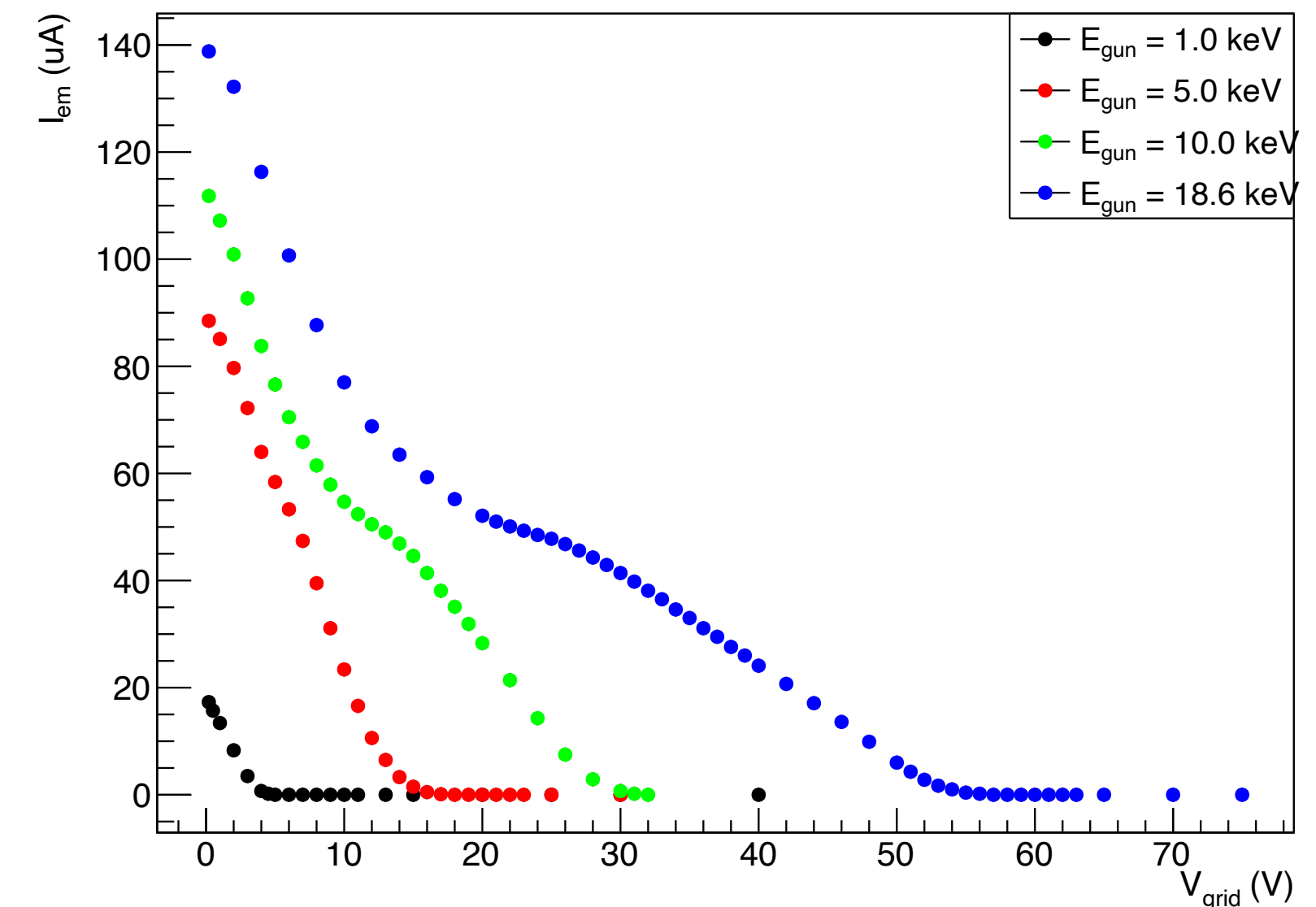
Beam Current Optimized by Wehnelt

Setup:

- Keithley 2450 SourceMeter + double Faraday cup
- Beam electron energy: 1 keV, 5 keV, 10 keV, 18.6 keV
- Source voltage (V_{source}) set to 1.521 V
- Focusing & deflection voltages optimized through Phosphor screen for each energy
- Base pressure: 10^{-7} mbar

Results:

- Similar behaviors, different V_{grid} optimizing beam current
- Better $I_{\text{beam}}/I_{\text{em}}$ ratio for lower electron energies

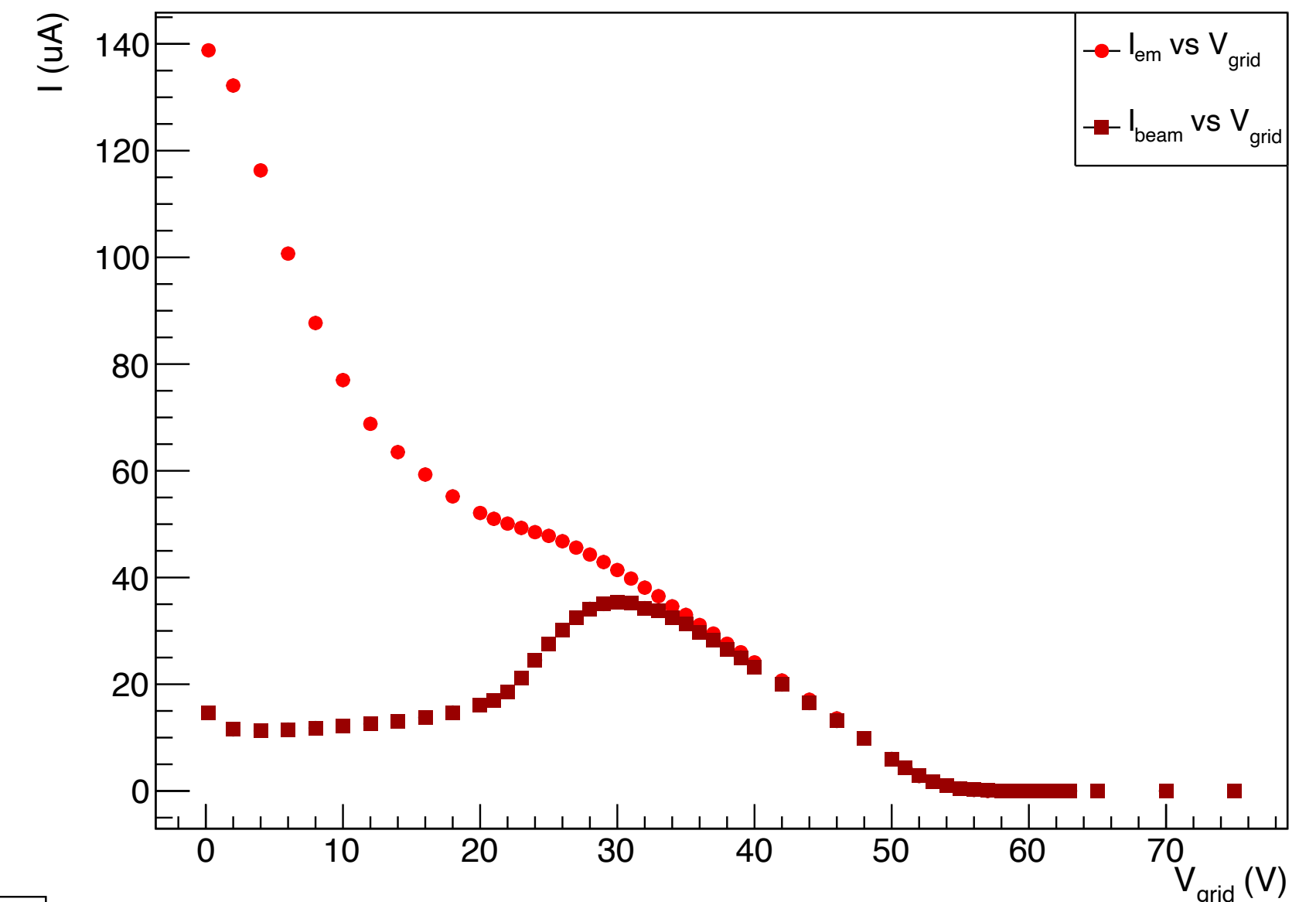


Up to 10^{-4} Reduction Factor

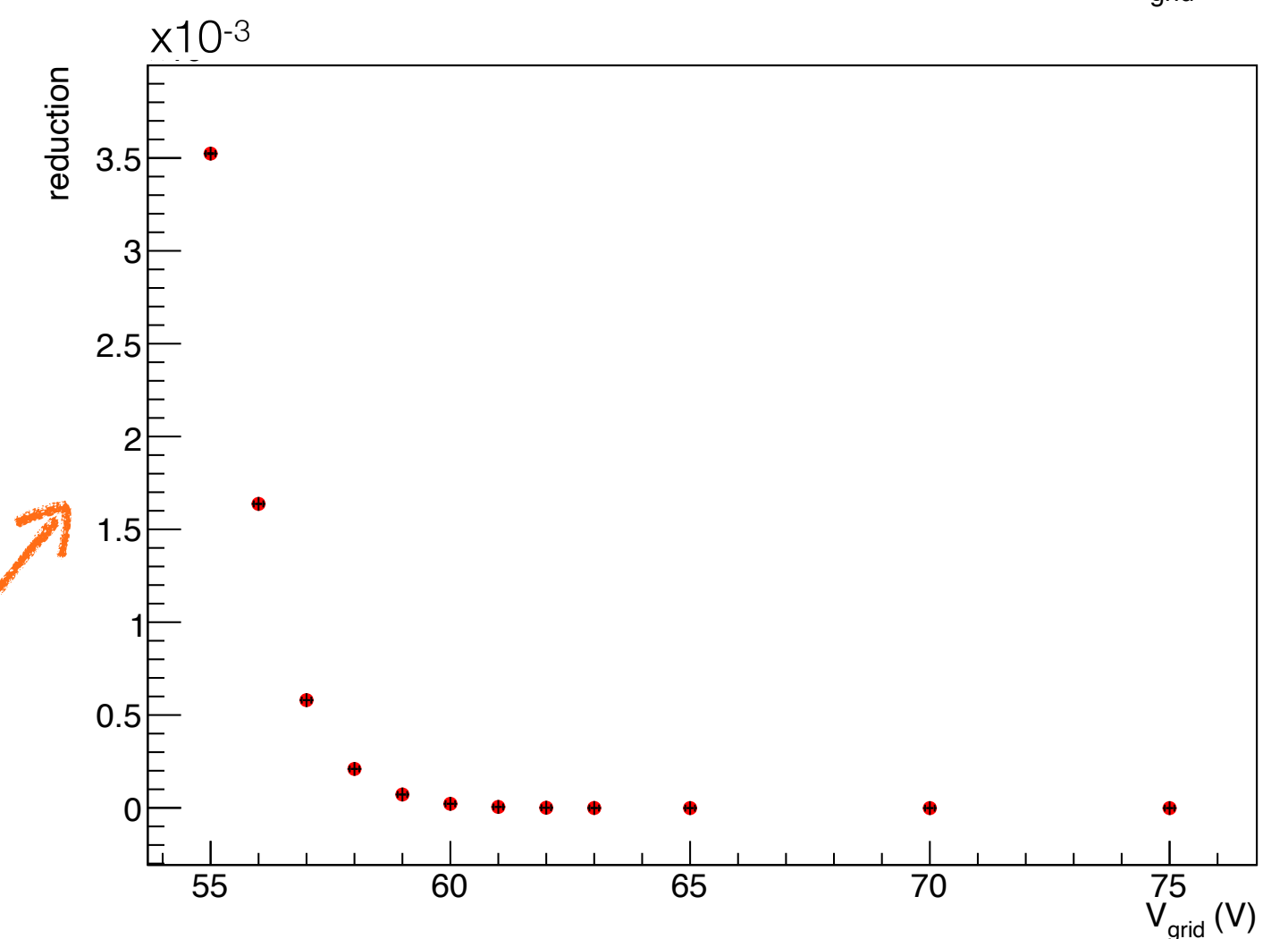
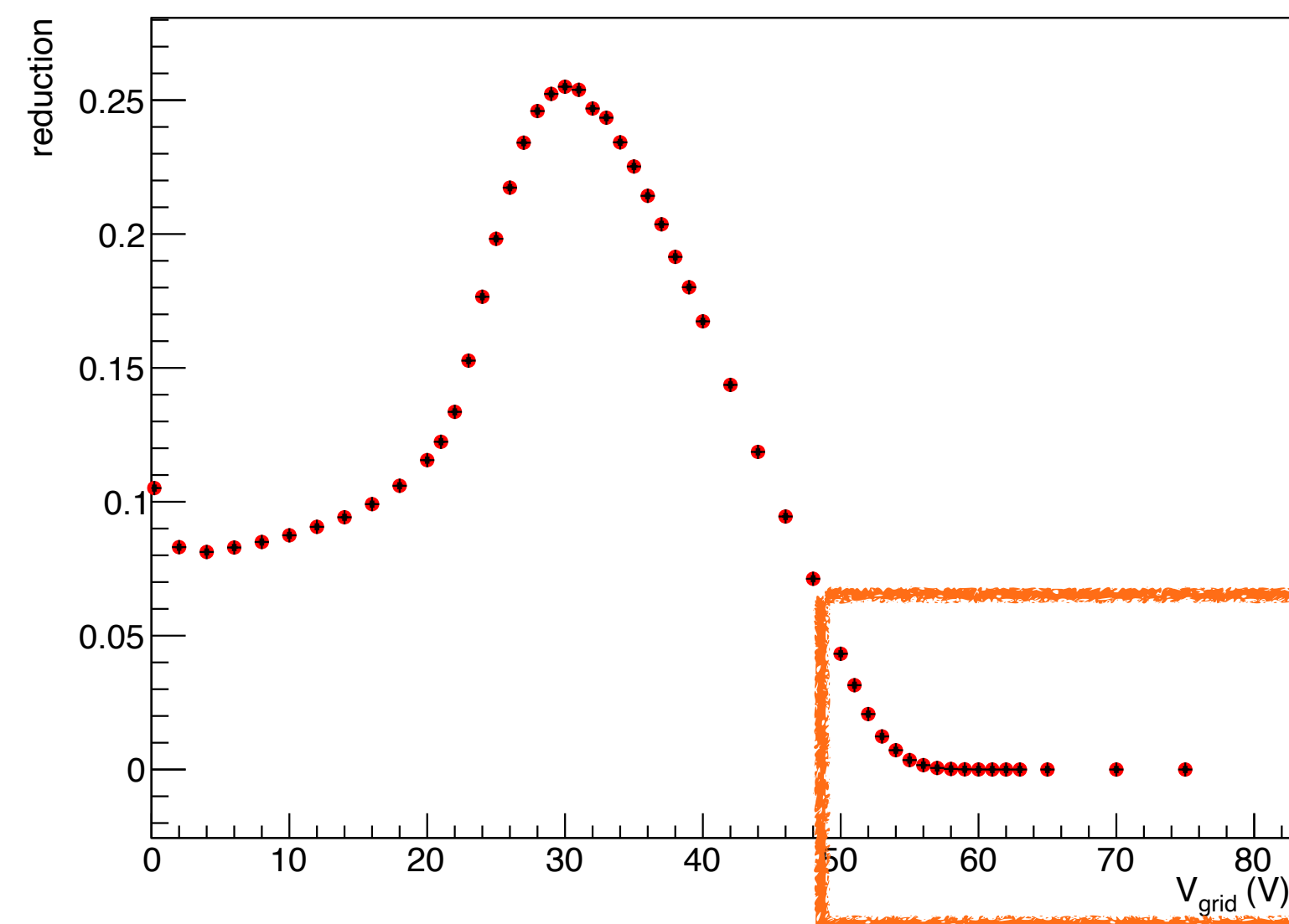
- ▶ Let's define:
 - "collection" efficiency $\epsilon = I_{beam}/I_{em}$
 - reduction factor $r = I_{beam}/I_{em}(V_{grid} = 0V)$

▶ Focusing on run @ 18.6 keV:

- beam current I_{beam} maximized for $V_{grid} = 30$ kV
- ϵ from 11% to ~100% for $V_{grid} > 45$ kV
- $r > 10^{-4}$ for $V_{grid} > 57$ kV

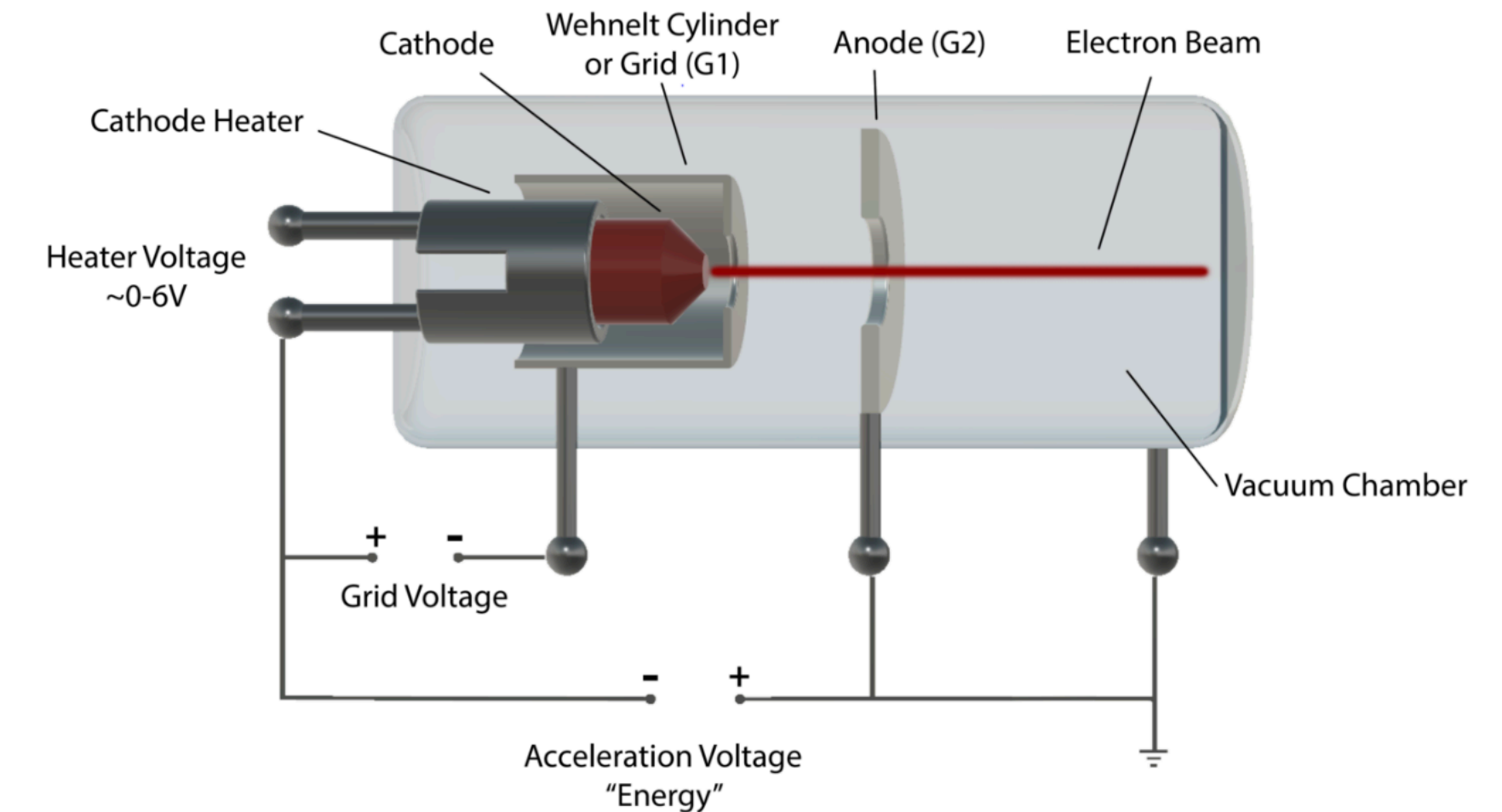


from 140 μ A to 700 pA!
not able to read
higher reduction
for instrumental limit

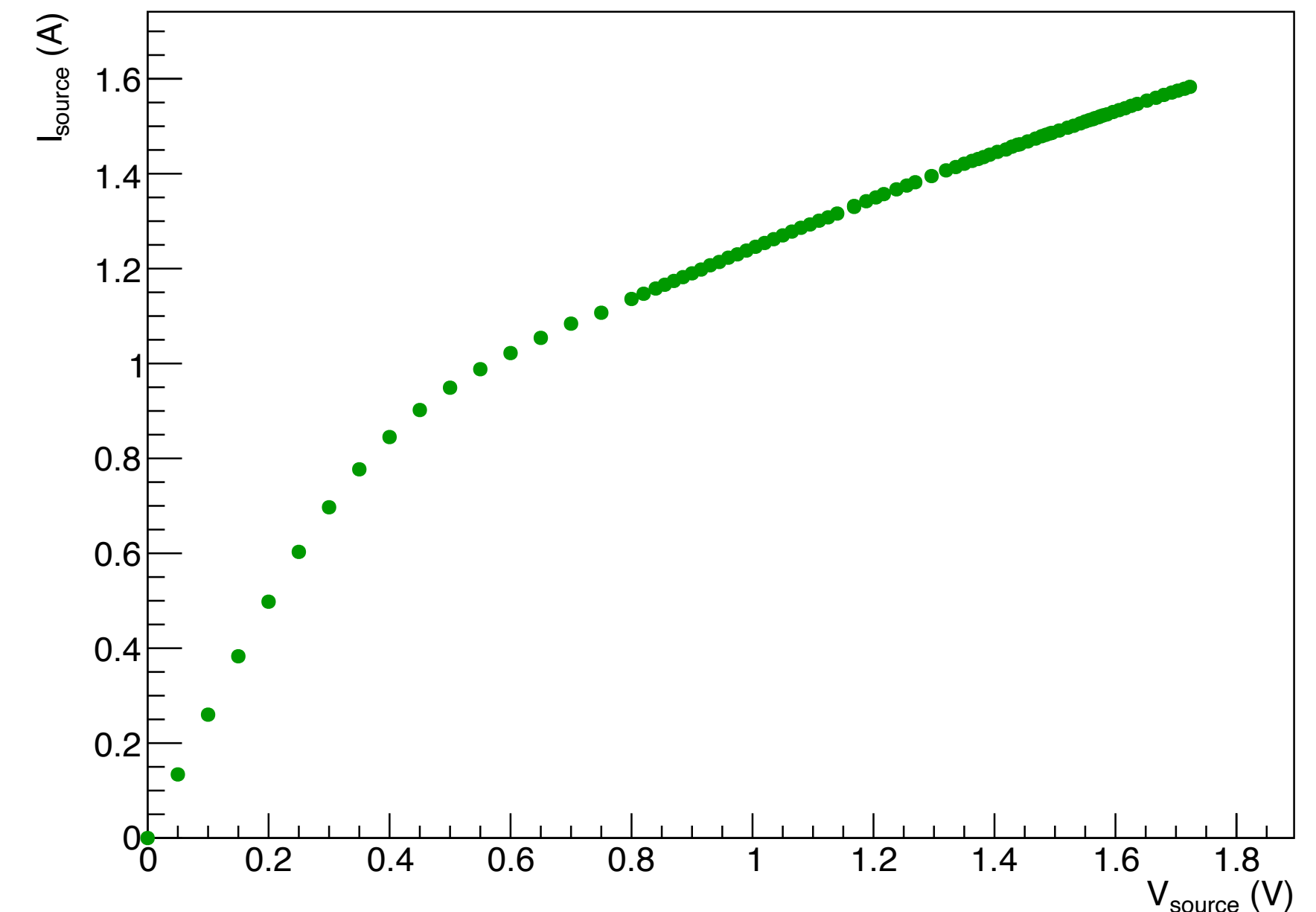


I-V Source Curve Linear in Emission Region

- ▶ Source = Refractory metal thermionic emitter
 - Tantalum disc, diameter 25 mm on tungsten hairpin filament
 - Circular, planar emission surface
 - Emitting electrons when filament heated by voltage source with energy spread 0.5 eV



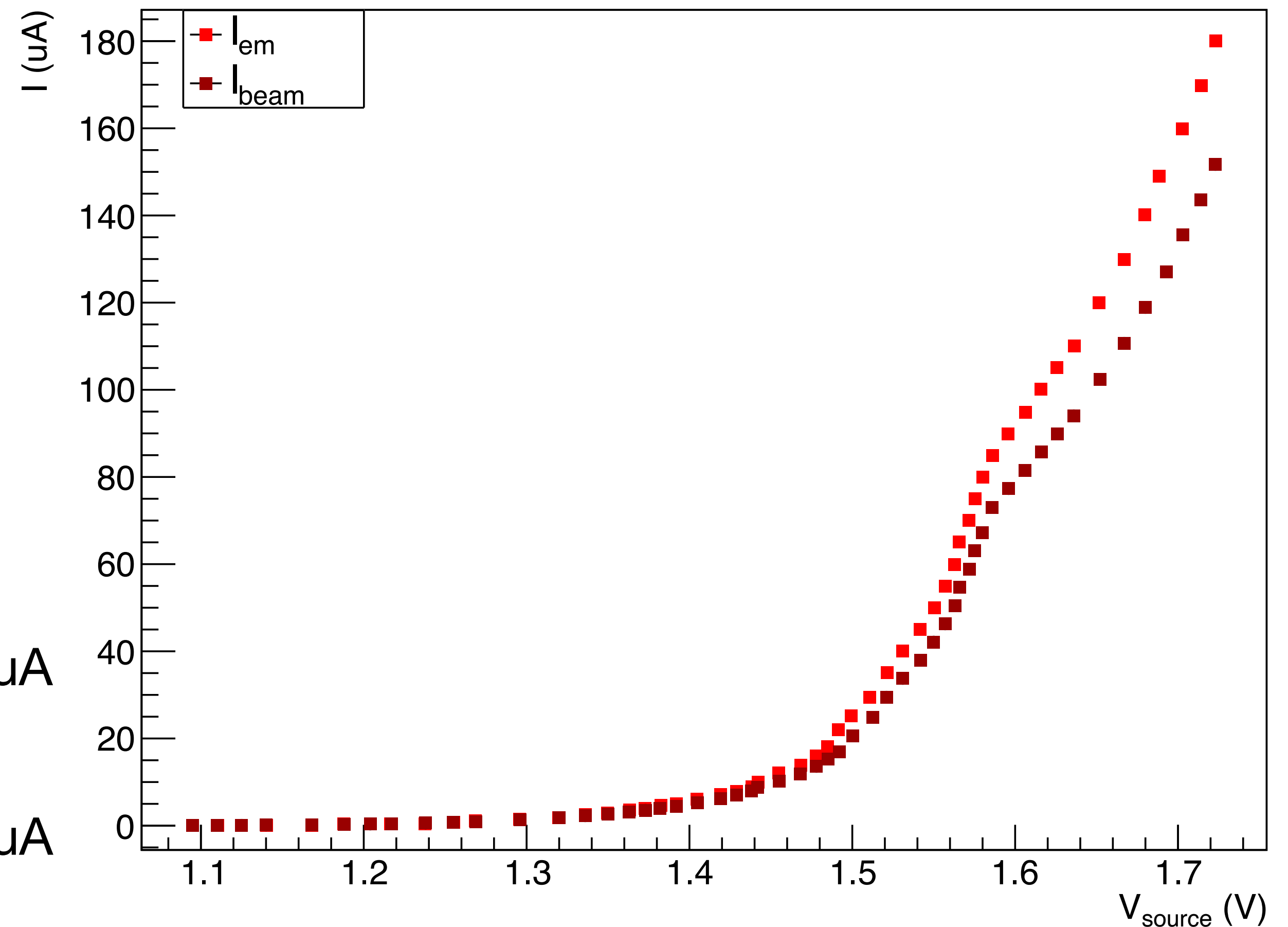
- ▶ Both voltage applied & current in filament displayed on power supply monitor
- ▶ I-V curve to characterize source
 - Linear behavior in the emission region ($V_{\text{source}} > 1 \text{ V}$)
 - ~1 day stabilization



Agreement Between Measured & Emitted Current

Setup:

- Keithley 2450 SourceMeter + double FC
- 18.6 keV electron energy
- $V_{\text{grid}} = 30 \text{ V}$ (I_{beam} optimization value)
- Focusing & deflection voltages optimized through Phosphor screen
- Base pressure: 10^{-7} mbar
- I_{em} in *controlled mode* from $0.1 \text{ } \mu\text{A}$ to $180 \text{ } \mu\text{A}$



▶ Same behaviour, $\sim 100\%$ efficiency for $I < 10 \text{ } \mu\text{A}$

▶ Discrepancy & stabilization time increase with V_{source} increasing

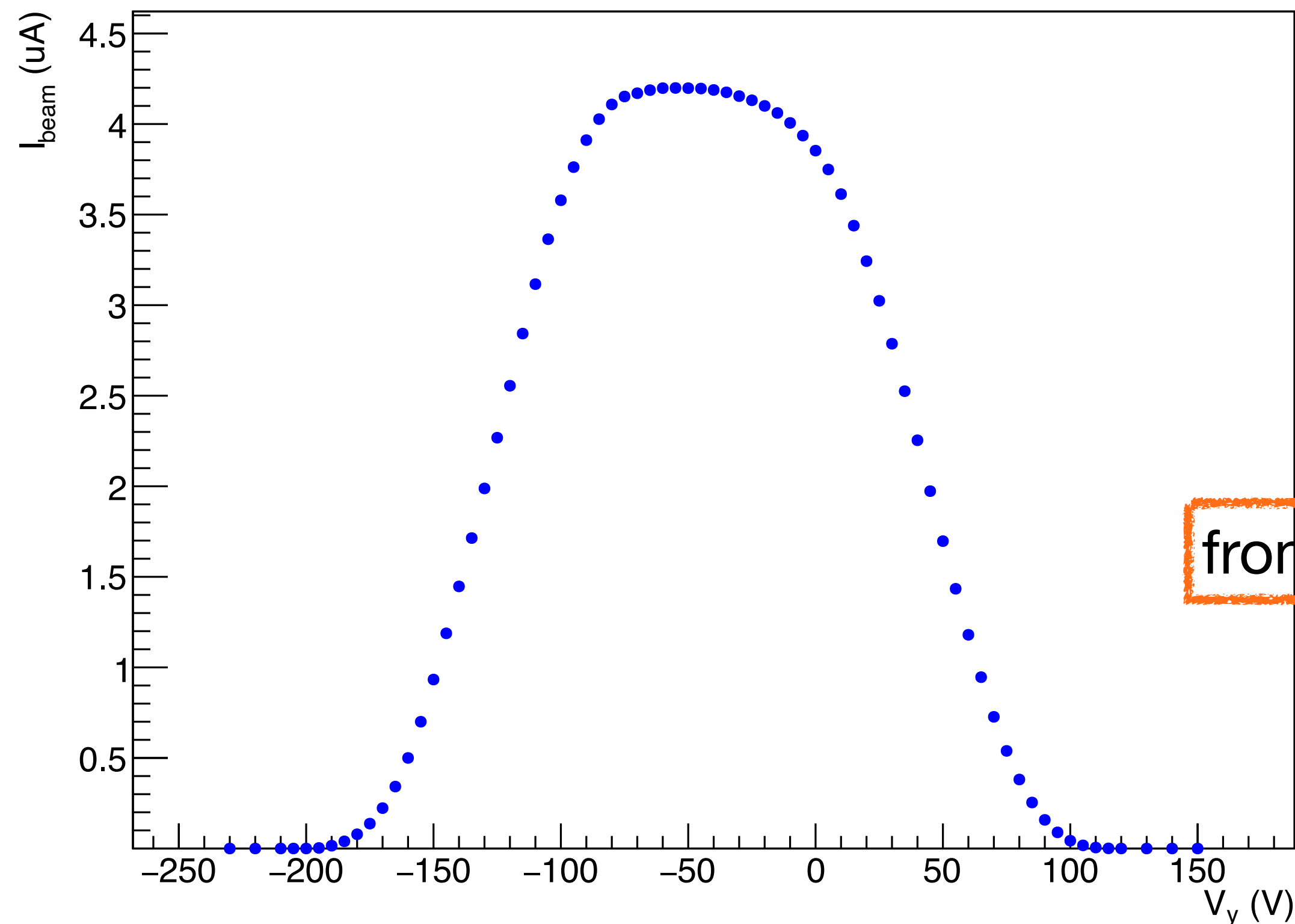
Preliminary Estimate of Beam Size

- ▶ Aims: estimate beam size + find correlation deflection voltage - position shift
- ▶ Scan of 3 mm Faraday cup hole moving beam with deflection voltages

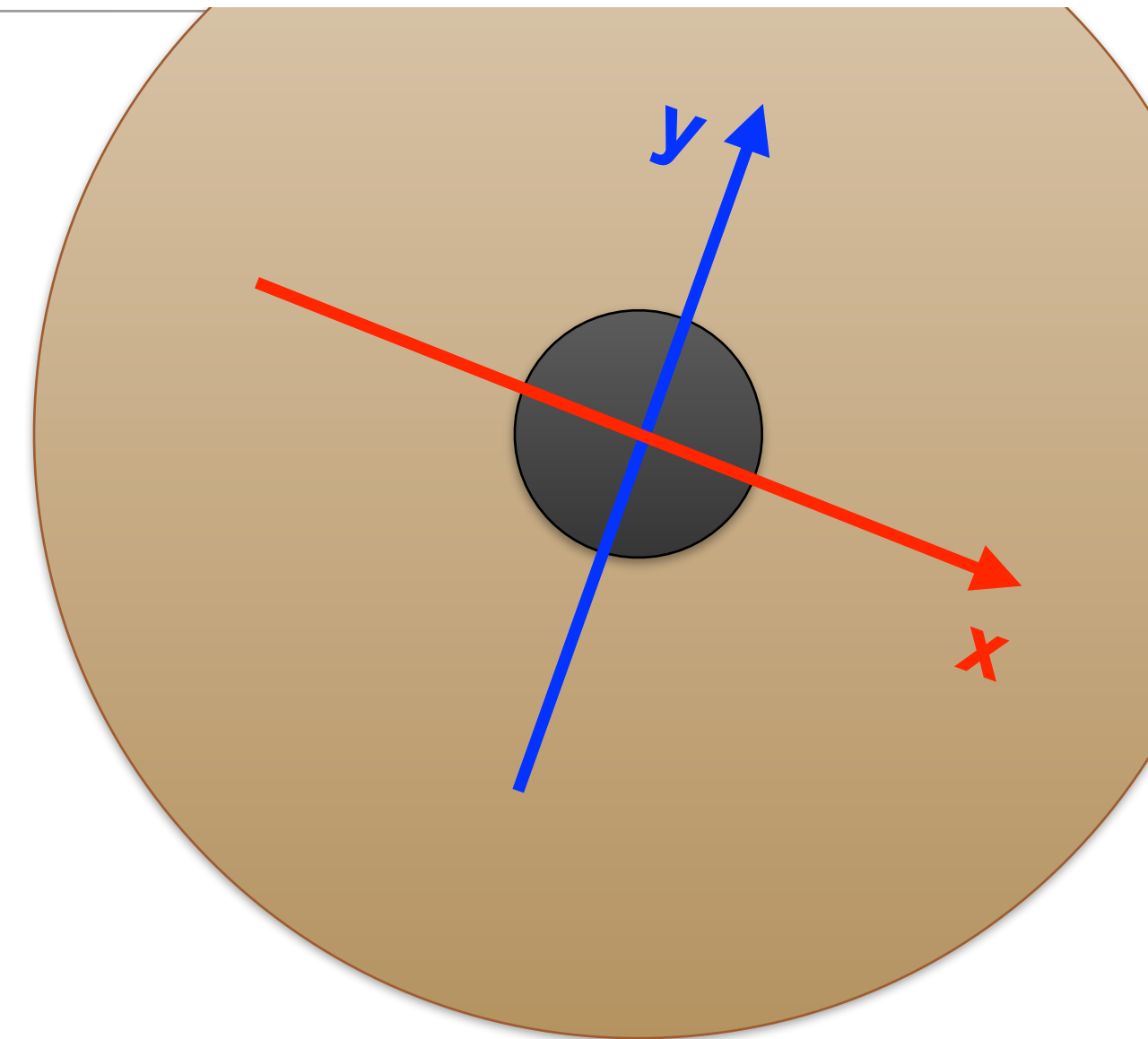
- I_{em} fixed to 5 μA
- V_y from -240 V to 150 V with 5 V steps

Result = convolution of

- gaussian (e-gun spatial current distrib)
- step function (FC hole)

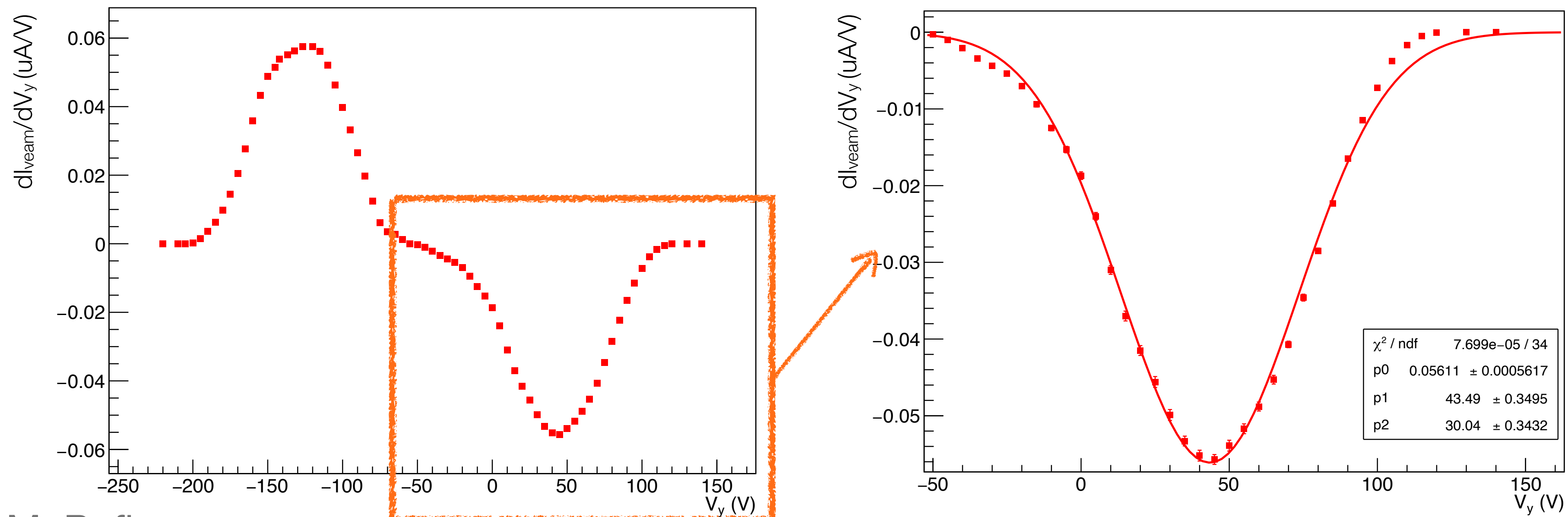


from rise & fall info



Sub-mm Spot Size

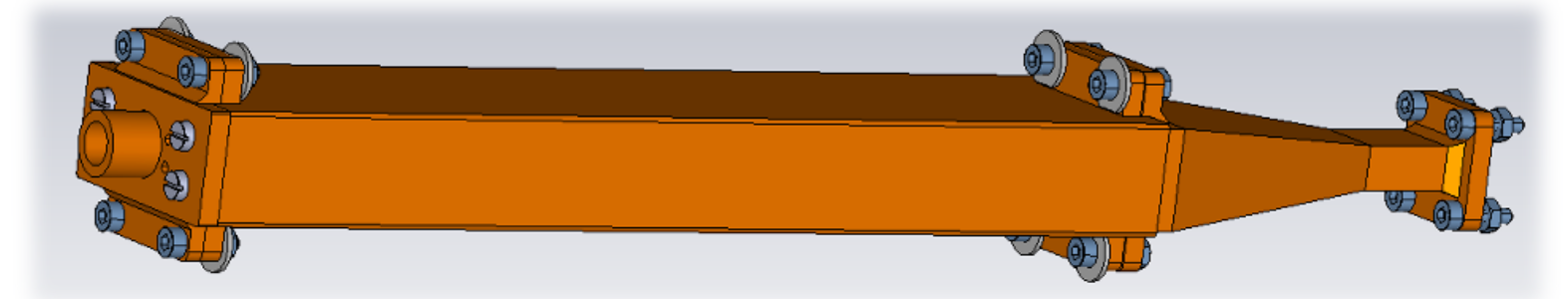
- ▶ From 1st derivative of I_{beam} vs V_y points (computed as $I_{\text{beam}}(V_y^i) - I_{\text{beam}}(V_y^{i-1}) / V_y^i - V_y^{i-1}$)
 - Gaussians reflecting beam spatial distribution with
 - Distance (peak to peak) $\simeq 170$ V = FC hole diameter = 3 mm \rightarrow 1 V = 0.0176 mm
 - $\sigma = 30 \pm 0.3$ V (fitted from 2nd gaussian) \rightarrow $\sigma = 0.53$ mm



Electron Injection in the Trap: The Magnet

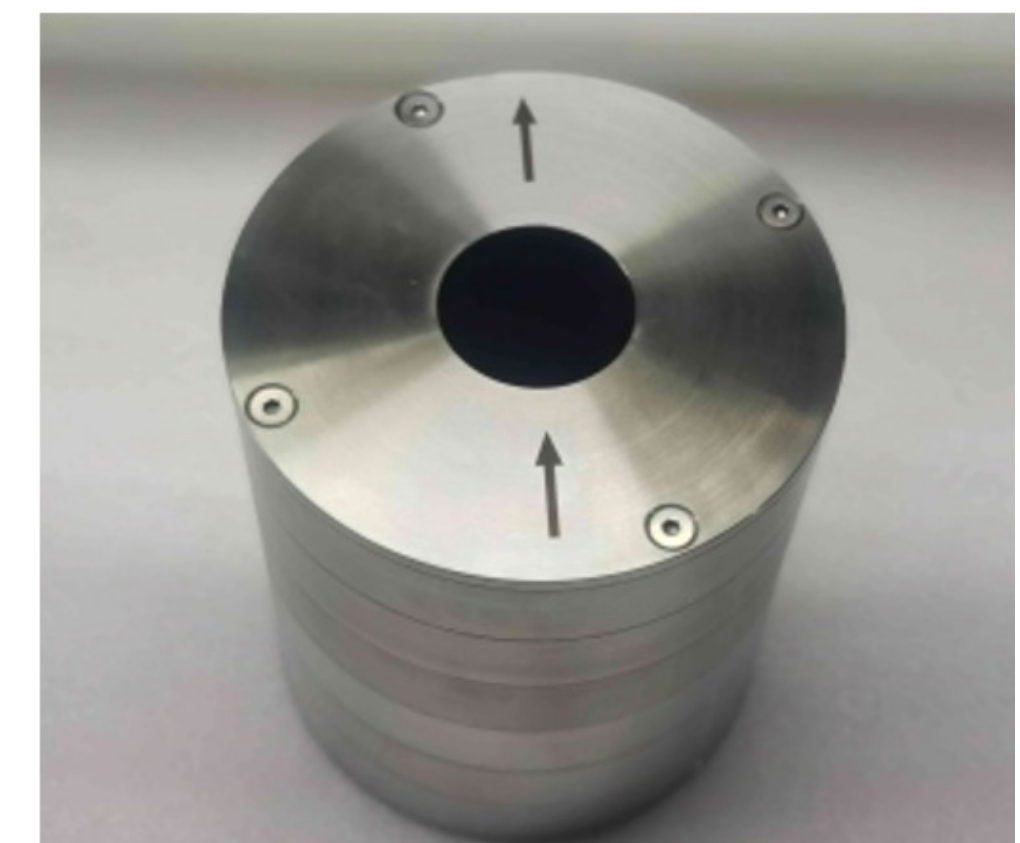
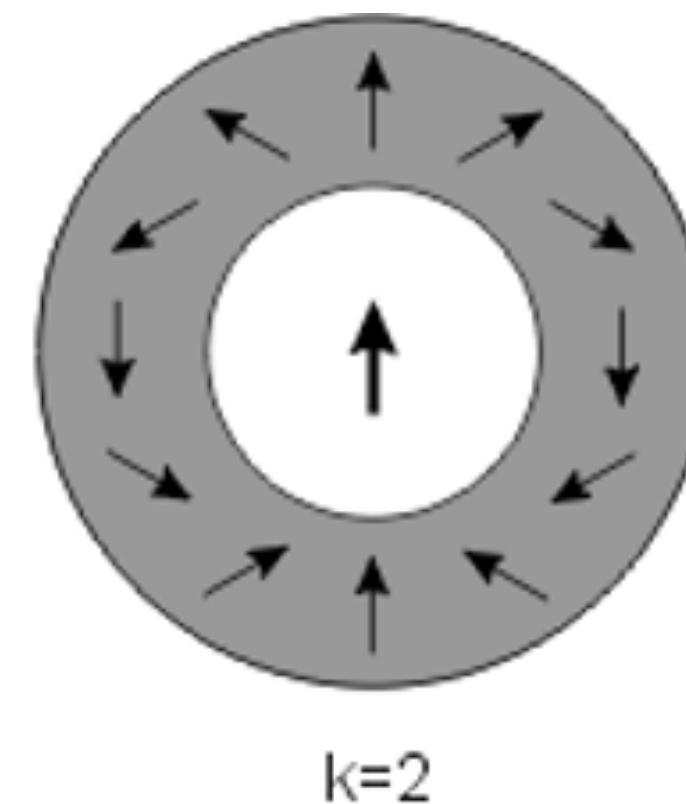
▶ Aim: simulate injection of beam electrons in actual RF region setup in LNGS (F. Virzi talk)

- Now: ^{83m}Kr injection \rightarrow 30.4 keV e^- (L line) produced in random point of trap
- With e-gun: 18.6 keV e^- with more controlled initial info



▶ Magnet in LNGS:

- Halbach cylinder permanent magnet
- 1 T uniform magnetic field in limited region inside
- Just z profile of B module given
- Field lines difficult to simulate (field produced by array of magnets)



Exploiting Laplace Equation for Scalar Potential

▶ Aim: know magnetic field behavior **outside** magnet to simulate e⁻ injection

▶ No sources in region of interest → governing laws:

▶ Procedure:

1. Solve Laplace equation with **Neumann boundary conditions** = B_{\perp} on infinite plane
2. Derive \mathbf{B} from ϕ_m
3. Outcome = magnetic field lines

▶ Only need to measure B_{\perp} on “infinite” plane

- **Gauss's Law for Magnetism:**
 $\nabla \cdot \mathbf{B} = 0$ (No monopoles)

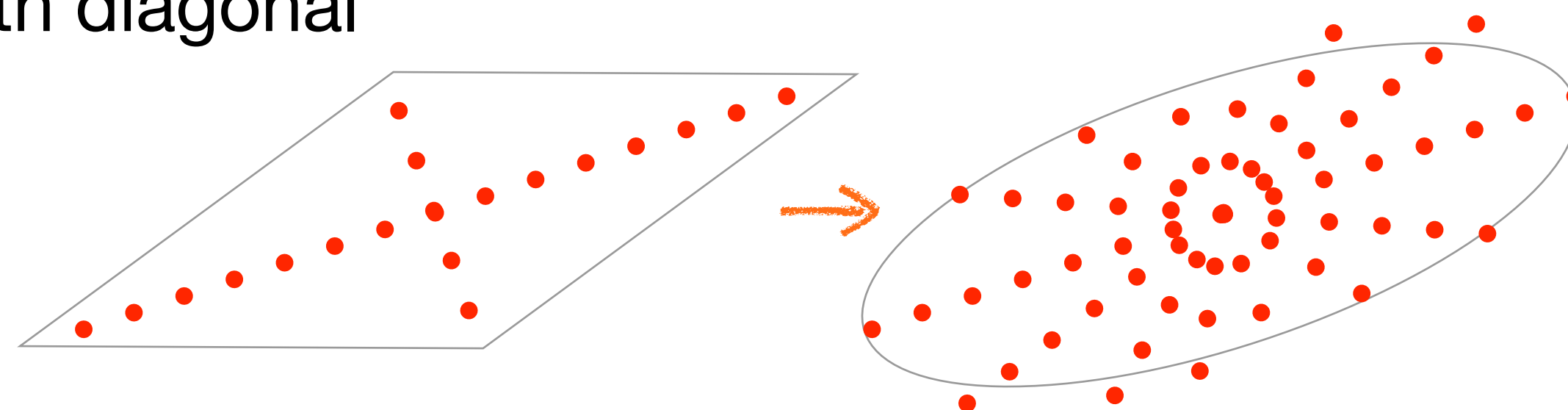
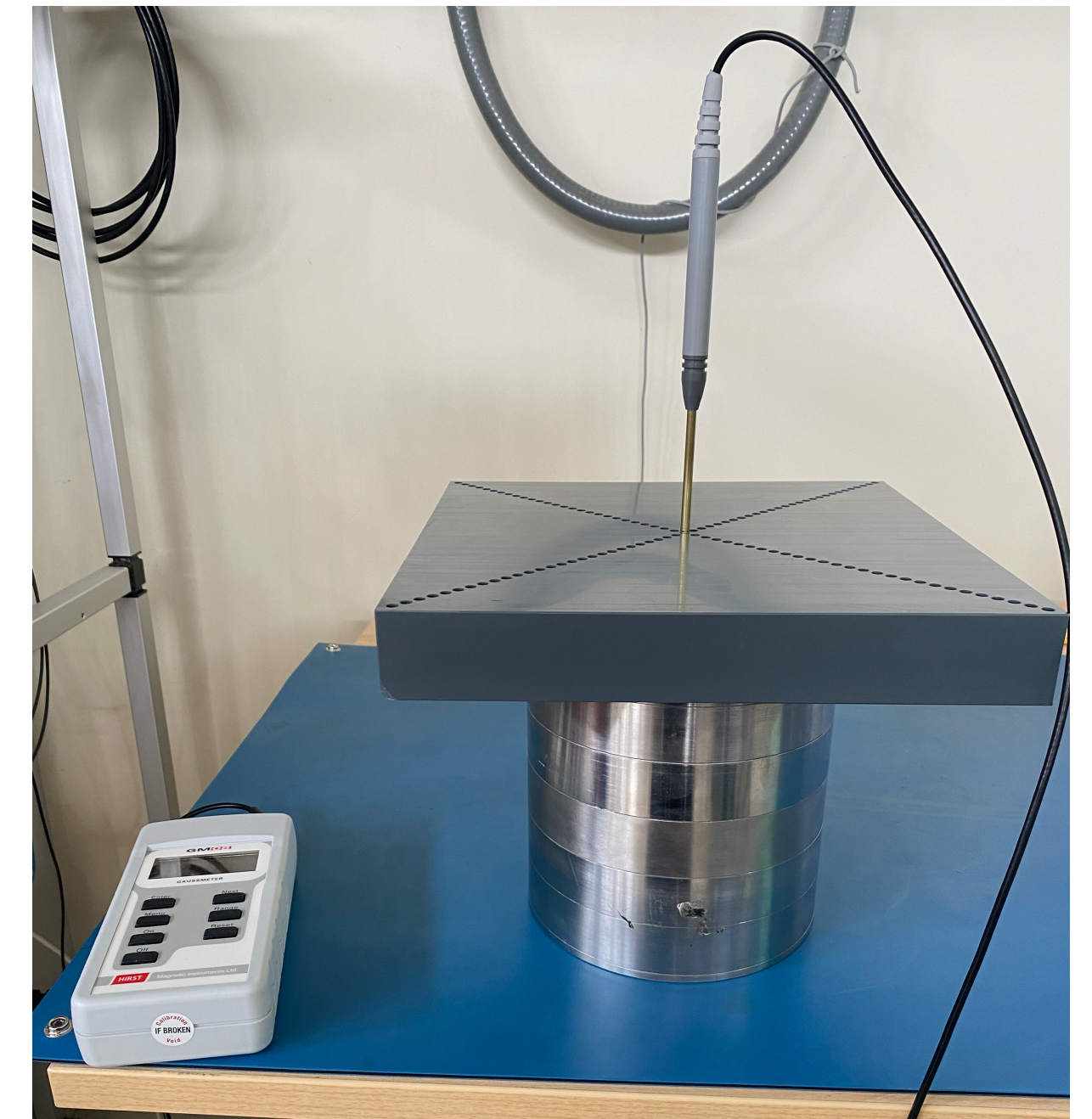
- **Ampère's Law (Static, No Currents):**
 $\nabla \times \mathbf{B} = 0$ (Field is curl – free)

- **Implications:**
 - Existence of a scalar potential:
 $\mathbf{B} = -\nabla \phi_m$

 - Laplace's Equation for ϕ_m :
 $\nabla^2 \phi_m = 0$

Measure of Boundary Conditions

- ▶ Aim:
 - measure B_{\perp} on infinite plane outside magnet
 - plane // to cylinder face, 3 mm from it
- ▶ Setup:
 - Halbach magnet dismounted from RF setup
 - Hirst GM08 Gaussmeter
 - cap by LNGS Mechanics Workshop with slots for inserting probe 7 mm apart on both diagonal



ONGOING!
 measurement planned
 this week

From Measurements to Simulation Setup

▶ Given boundary conditions → solution of Laplace equation

- using COMSOL simulation software based on advanced numerical methods (in collab with Dr. Carlo Rizza from UnivAq)
- Result = Magnetic Field Map for the whole region of interest in txt (or other format) file



▶ Next steps:

- Map Upload & Implementation of possible electrodes configurations in CST
- Multiparticle Simulations with measured characteristics of electrons from E-gun

- ▶ In CST
- ▶ Using Lorentz4 ROOT code →

ONGOING!
new implementation with Dr. Nicola Rossi to read electric & magnetic fields from files

Recap & Next Steps

- ✓ Beam Current with reduction factor 10^{-4} exploiting Wehnelt grid
- ✓ 1st beam size estimate of ~ 0.5 mm
+ correlation deflection voltage - position shift
- ✓ I vs V from $0.1 \mu\text{A}$ to $180 \mu\text{A}$
- ✓ Setup to measure B_{\perp} on extended plane ready



TO DO

- Beam Current with femtoammeter to probe higher reduction
- Estimate using manual shift via feedthrough
+ optimize focusing voltage
- Curve down to pA (or fA)
- Measurement, COMSOL solution, File Upload, Geometry implementation, Multiparticle Simulation
- Helmholtz coils cage